

# Hao Zhu

## List of Publications by Year in descending order

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docs citations

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times ranked

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citing authors

#	ARTICLE	IF	CITATIONS
1	A Transistor-Level DFF Based on FinFET Technology for Low Power Integrated Circuits. IEEE Transactions on Circuits and Systems II: Express Briefs, 2022, 69, 584-588.	2.2	2
2	A high-speed 2D optoelectronic in-memory computing device with 6-bit storage and pattern recognition capabilities. Nano Research, 2022, 15, 2472-2478.	5.8	20
3	NBTI Mitigation by Optimized HKMG Thermal Processing in a FinFET Technology. IEEE Transactions on Electron Devices, 2022, 69, 905-909.	1.6	8
4	Mitigating the Length of Diffusion Effect by Back-End Design-Technology Cooptimization. IEEE Transactions on Electron Devices, 2022, 69, 1279-1283.	1.6	0
5	Precise CO <sub>2</sub> Reduction for Bilayer Graphene. ACS Central Science, 2022, 8, 394-401.	5.3	6
6	Band alignment of atomic layer deposited MoS <sub>2</sub> /(HfO <sub>2</sub> ) <sub>x</sub> (Al <sub>2</sub> O <sub>3</sub> ) <sub>x</sub> heterojunctions for device applications. Journal Physics D: Applied Physics, 2022, 55, 225102.	1.3	1
7	Multifunctional Logic-in-Memory Cell Based on Wafer-Scale MoS <sub>2</sub> Thin Films Prepared by Atomic Layer Deposition. Physica Status Solidi - Rapid Research Letters, 2022, 16, .	1.2	4
8	Gas sensing devices based on two-dimensional materials: a review. Nanotechnology, 2022, 33, 252001.	1.3	36
9	Integrated In-Sensor Computing Optoelectronic Device for Environment-Adaptable Artificial Retina Perception Application. Nano Letters, 2022, 22, 81-89.	4.5	104
10	High-Performance Lateral Avalanche Photodiode Based on Silicon-on-Insulator Structure. IEEE Electron Device Letters, 2022, 43, 1077-1080.	2.2	3
11	Amorphous semi-insulating Al-doped In <sub>2</sub> O <sub>3</sub> growth by atomic layer deposition for thin-film transistors. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2022, 40, .	0.9	3
12	Organic Optoelectronic Synaptic Devices for Energy-Efficient Neuromorphic Computing. IEEE Electron Device Letters, 2022, 43, 1089-1092.	2.2	14
13	Ultralow Power Wearable Organic Ferroelectric Device for Optoelectronic Neuromorphic Computing. Nano Letters, 2022, 22, 6435-6443.	4.5	32
14	Large-Scale Multilayer MoS <sub>2</sub> Nanosheets Grown by Atomic Layer Deposition for Sensitive Photodetectors. ACS Applied Nano Materials, 2022, 5, 10431-10440.	2.4	5
15	Forming-free flexible memristor with multilevel storage for neuromorphic computing by full PVD technique. Journal of Materials Science and Technology, 2021, 60, 21-26.	5.6	43
16	Flexible 3D memristor array for binary storage and multi-states neuromorphic computing applications. Information Materials, 2021, 3, 212-221.	8.5	52
17	Observation of different transport behaviors in a two-dimensional MoTe <sub>2</sub> field-effect transistor with engineered gate stack. Microelectronic Engineering, 2021, 237, 111497.	1.1	2
18	Design of Reading Circuit for High-Reliability 55-nm Split-Gate SuperFlash Technology. IEEE Solid-State Circuits Letters, 2021, 4, 117-120.	1.3	0

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19	Flexible boron nitride-based memristor for <i>in situ</i> digital and analogue neuromorphic computing applications. <i>Materials Horizons</i> , 2021, 8, 538-546.	6.4	73
20	Hafnium Oxide-Based Ferroelectric Devices for Computing-In-Memory Applications. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2021, 218, 2000635.	0.8	13
21	A Simple I-ToF Module Based on Avalanche Photodiode. <i>IEEE Photonics Technology Letters</i> , 2021, 33, 123-126.	1.3	2
22	Energy-efficient flexible photoelectric device with 2D/0D hybrid structure for bio-inspired artificial heterosynapse application. <i>Nano Energy</i> , 2021, 83, 105815.	8.2	42
23	Suppression of Stress-Induced Defects in FinFET by Implantation and STI Co-Optimization. <i>IEEE Transactions on Electron Devices</i> , 2021, 68, 2587-2589.	1.6	4
24	Performance improvement in p-Type WS <sub>2</sub> field-effect transistors with 1T phase contacts. <i>Nanotechnology</i> , 2021, 32, 345202.	1.3	4
25	An in-memory computing architecture based on two-dimensional semiconductors for multiply-accumulate operations. <i>Nature Communications</i> , 2021, 12, 3347.	5.8	46
26	Improving Low-Frequency Noise in 14-nm FinFET by Optimized High-k/Metal Gate Thermal Processing. <i>IEEE Electron Device Letters</i> , 2021, 42, 1112-1115.	2.2	6
27	HfZrO <sub>2</sub> -Based Ferroelectric Tunnel Junction With Crested Symmetric Band Structure Engineering. <i>IEEE Electron Device Letters</i> , 2021, 42, 1311-1314.	2.2	15
28	Growth Mechanisms and Morphology Engineering of Atomic Layer-Deposited WS <sub>2</sub> . <i>ACS Applied Materials &amp; Interfaces</i> , 2021, 13, 43115-43122.	4.0	12
29	Ultralow-Power Synaptic Transistor Based on Wafer-Scale MoS <sub>2</sub> Thin Film for Neuromorphic Application. <i>IEEE Electron Device Letters</i> , 2021, 42, 1555-1558.	2.2	10
30	Reconfigurable optoelectronic memristor for in-sensor computing applications. <i>Nano Energy</i> , 2021, 89, 106291.	8.2	66
31	CMOS back-end compatible memristors for <i>in situ</i> digital and neuromorphic computing applications. <i>Materials Horizons</i> , 2021, 8, 3345-3355.	6.4	12
32	Ferroelectric Field-Effect Transistors Based on WSe <sub>2</sub> /CuInP <sub>2</sub> S <sub>6</sub> Heterostructures for Memory Applications. <i>ACS Applied Electronic Materials</i> , 2021, 3, 4711-4717.	2.0	23
33	Gate Oxide and Implantation Process Co-Optimization for Low-Power MCU Applications. <i>IEEE Journal of the Electron Devices Society</i> , 2021, 9, 1055-1059.	1.2	1
34	A Dual-Gate MoS <sub>2</sub> Photodetector Based on Interface Coupling Effect. <i>Small</i> , 2020, 16, e1904369.	5.2	65
35	Laterally Coupled 2D MoS <sub>2</sub> Synaptic Transistor With Ion Gating. <i>IEEE Electron Device Letters</i> , 2020, 41, 1424-1427.	2.2	16
36	MoS <sub>2</sub> -on-AlN Enables High-Performance MoS <sub>2</sub> Field-Effect Transistors through Strain Engineering. <i>ACS Applied Materials &amp; Interfaces</i> , 2020, 12, 54972-54979.	4.0	11

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37	Flexible organic field-effect transistor arrays for wearable neuromorphic device applications. <i>Nanoscale</i> , 2020, 12, 23150-23158.	2.8	33
38	MoS <sub>2</sub> -based ferroelectric field-effect transistor with atomic layer deposited Hf <sub>0.5</sub> Zr <sub>0.5</sub> O <sub>2</sub> films toward memory applications. <i>AIP Advances</i> , 2020, 10, .	0.6	10
39	Ultralow Power Wearable Heterosynapse with Photoelectric Synergistic Modulation. <i>Advanced Science</i> , 2020, 7, 1903480.	5.6	95
40	Three-Dimensional Nanoscale Flexible Memristor Networks with Ultralow Power for Information Transmission and Processing Application. <i>Nano Letters</i> , 2020, 20, 4111-4120.	4.5	134
41	Multifunctional black phosphorus/MoS <sub>2</sub> van der Waals heterojunction. <i>Nanophotonics</i> , 2020, 9, 2487-2493.	2.9	17
42	Room-temperature developed flexible biomemristor with ultralow switching voltage for array learning. <i>Nanoscale</i> , 2020, 12, 9116-9123.	2.8	33
43	MoS <sub>2</sub> -based Charge-trapping synaptic device with electrical and optical modulated conductance. <i>Nanophotonics</i> , 2020, 9, 2475-2486.	2.9	36
44	Realizing an Omega-Shaped Gate MoS <sub>2</sub> Field-Effect Transistor Based on a SiO <sub>2</sub> /MoS <sub>2</sub> Core-Shell Heterostructure. <i>ACS Applied Materials &amp; Interfaces</i> , 2020, 12, 14308-14314.	4.0	22
45	Homogeneous dual-gate MoS <sub>2</sub> field-effect transistors integrated by atomic layer deposition-based film synthesis. <i>Journal of Materials Science: Materials in Electronics</i> , 2020, 31, 5485-5491.	1.1	3
46	ReS <sub>2</sub> Charge Trapping Synaptic Device for Face Recognition Application. <i>Nanoscale Research Letters</i> , 2020, 15, 2.	3.1	12
47	An Enhanced Floating Gate Memory for the Online Training of Analog Neural Networks. <i>IEEE Journal of the Electron Devices Society</i> , 2020, 8, 84-91.	1.2	0
48	Backside passivation for improving the noise performance in CMOS image sensor. <i>AIP Advances</i> , 2020, 10, .	0.6	1
49	Atomic layer deposited 2D MoS <sub>2</sub> atomic crystals: from material to circuit. <i>Nano Research</i> , 2020, 13, 1644-1650.	5.8	24
50	Controlled growth of MoS <sub>2</sub> by atomic layer deposition on patterned gold pads. <i>Journal of Crystal Growth</i> , 2020, 541, 125683.	0.7	10
51	Channel-protecting fabrication of top-gate MoS <sub>2</sub> transistor arrays. <i>Semiconductor Science and Technology</i> , 2020, 35, 075006.	1.0	2
52	Multibit non-volatile memory based on WS <sub>2</sub> transistor with engineered gate stack. <i>AIP Advances</i> , 2020, 10, .	0.6	2
53	Observation and control of the anomalous Aharonov-Bohm oscillation in enhanced-mode topological insulator nanowire field-effect transistors. <i>Applied Physics Letters</i> , 2019, 115, 073107.	1.5	4
54	Feasibility of Large-Scale MoS <sub>2</sub> Thin-Film Transistors on a GaN Substrate. <i>ACS Applied Electronic Materials</i> , 2019, 1, 1418-1423.	2.0	5

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55	A Symmetric Tunnel Field-Effect Transistor Based on MoS <sub>2</sub> /Black Phosphorus/MoS <sub>2</sub> Nanolayered Heterostructures. ACS Applied Nano Materials, 2019, 2, 5674-5680.	2.4	27
56	Fully transparent, flexible and waterproof synapses with pattern recognition in organic environments. Nanoscale Horizons, 2019, 4, 1293-1301.	4.1	40
57	Atomic Layer Deposited Hf <sub>0.5</sub> Zr <sub>0.5</sub> O <sub>2</sub> -based Flexible Memristor with Short/Long-Term Synaptic Plasticity. Nanoscale Research Letters, 2019, 14, 102.	3.1	38
58	Fast-Response Inverter Arrays Built on Wafer-Scale MoS <sub>2</sub> by Atomic Layer Deposition. Physica Status Solidi - Rapid Research Letters, 2019, 13, 1900018.	1.2	16
59	Synthesis of large-scale few-layer PtS <sub>2</sub> films by chemical vapor deposition. AIP Advances, 2019, 9, .	0.6	42
60	Optimization of Defects in Large-Area Synthetic MoS <sub>2</sub> Thin Films by CS <sub>2</sub> Treatment for Switching and Sensing Devices. ACS Applied Nano Materials, 2019, 2, 7810-7818.	2.4	15
61	High-Performance ReS <sub>2</sub> FET for Optoelectronics and Flexible Electronics Applications. IEEE Electron Device Letters, 2019, 40, 123-126.	2.2	10
62	Ni-assisted crystallization of few-layer transition metal dichalcogenide ultra-thin films. Journal of Materials Science: Materials in Electronics, 2019, 30, 4085-4092.	1.1	5
63	Wafer-scale transferred multilayer MoS <sub>2</sub> for high performance field effect transistors. Nanotechnology, 2019, 30, 174002.	1.3	37
64	Stateful Logic Operations Implemented With Graphite Resistive Switching Memory. IEEE Electron Device Letters, 2018, 39, 607-609.	2.2	12
65	Ferroelectric HfZrOx-based MoS <sub>2</sub> negative capacitance transistor with ITO capping layers for steep-slope device application. Applied Physics Letters, 2018, 112, .	1.5	28
66	Thickness Dependence of Low-Frequency Noise in MoS <sub>2</sub> Field-Effect Transistors With Enhanced Back-Gate Control. IEEE Electron Device Letters, 2018, 39, 739-741.	2.2	4
67	High performance few-layer MoS <sub>2</sub> transistor arrays with wafer level homogeneity integrated by atomic layer deposition. 2D Materials, 2018, 5, 015028.	2.0	30
68	Flexible Electronic Synapses for Face Recognition Application with Multimodulated Conductance States. ACS Applied Materials & Interfaces, 2018, 10, 37345-37352.	4.0	72
69	Ultra-low power Hf <sub>0.5</sub> Zr <sub>0.5</sub> O <sub>2</sub> based ferroelectric tunnel junction synapses for hardware neural network applications. Nanoscale, 2018, 10, 15826-15833.	2.8	165
70	A Semi-Floating Gate Transistor with Enhanced Embedded Tunneling Field Effect Transistor. IEEE Electron Device Letters, 2018, , 1-1.	2.2	1
71	Improved integration of ultra-thin high-k dielectrics in few-layer MoS <sub>2</sub> FET by remote forming gas plasma pretreatment. Applied Physics Letters, 2017, 110, .	1.5	44
72	Realizing Stable p-Type Transporting in Two-Dimensional WS <sub>2</sub> Films. ACS Applied Materials & Interfaces, 2017, 9, 18215-18221.	4.0	47

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73	A two-dimensional semiconductor transistor with boosted gate control and sensing ability. Science Advances, 2017, 3, e1602246.	4.7	65
74	Top-Down Integration of Molybdenum Disulfide Transistors with Wafer-Scale Uniformity and Layer Controllability. Small, 2017, 13, 1603157.	5.2	45
75	Impact of Metal Contacts on the Performance of Multilayer HfS <sub>2</sub> Field-Effect Transistors. ACS Applied Materials & Interfaces, 2017, 9, 26996-27003.	4.0	30
76	Light-erasable embedded charge-trapping memory based on MoS <sub>2</sub> for system-on-panel applications. Applied Physics Letters, 2017, 111, .	1.5	8
77	Dirac fermions induced in strained zigzag phosphorus nanotubes and their applications in field effect transistors. Physical Chemistry Chemical Physics, 2016, 18, 32521-32527.	1.3	3
78	Novel Two-Dimensional Mechano-Electric Generators and Sensors Based on Transition Metal Dichalcogenides. Scientific Reports, 2015, 5, 12854.	1.6	21
79	A computational study of the electronic properties of one-dimensional armchair phosphorene nanotubes. Journal of Applied Physics, 2015, 118, .	1.1	45
80	Redox-Active Molecular Nanowire Flash Memory for High-Endurance and High-Density Nonvolatile Memory Applications. ACS Applied Materials & Interfaces, 2015, 7, 27306-27313.	4.0	59
81	Influence of Metal-MoS <sub>2</sub> Interface on MoS <sub>2</sub> Transistor Performance: Comparison of Ag and Ti Contacts. ACS Applied Materials & Interfaces, 2015, 7, 1180-1187.	4.0	97
82	Discrete charge states in nanowire flash memory with multiple Ta <sub>2</sub> O <sub>5</sub> charge-trapping stacks. Applied Physics Letters, 2014, 104, .	1.5	25
83	High performance topological insulator nanowire field-effect transistors. , 2013, , .		2
84	Topological Insulator Bi <sub>2</sub> Se <sub>3</sub> Nanowire High Performance Field-Effect Transistors. Scientific Reports, 2013, 3, .	1.6	73
85	Non-volatile memory with self-assembled ferrocene charge trapping layer. Applied Physics Letters, 2013, 103, .	1.5	19
86	Self-aligned multi-channel silicon nanowire field-effect transistors. , 2011, , .		0